

TRANSMITTAL

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**Title of
Invention****[METHOD OF FABRICATING SHALLOW TRENCH ISOLATION
STRUCTURE FOR REDUCING WAFER SCRATCH]**

Application Number :

Date :

First Named Applicant: Mr. Jason Lu

Confirmation Number:

Attorney Docket Number: 13155-US-PA

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Submitted By:**Elec. Sign.****Sign. Capacity**

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| Documents being submitted: | Files |
|---|--|
| us-assignment | 13155-usassn.xml us-assignment.xml us-assignment.dtd 13155assignment01.tif 13155assignment02.tif |
| us-request | 13155-usrequ.xml us-request.dtd us-request.xml |
| us-fee-sheet | 13155-usfees.xml us-fee-sheet.xml us-fee-sheet.dtd |
| us-declaration | 13155declaration01.tif |
| application-body | 13155-trans.xml us-application-body.xml application-body.dtd wipo.ent mathml2.dtd mathml2-qname-1.mod isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isogr3.ent isomfrk.ent isomopf.ent isomscr.ent isotech.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isolat1.ent isolat2.ent isonum.ent isopub.ent mmlextra.ent mmlalias.ent soextblx.dtd 13155US0001.tif 13155US0002.tif 13155US0003.tif 13155US0004.tif 13155US0005.tif 13155US0006.tif |
| us-declaration | 13155declaration02.tif |
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